1/6

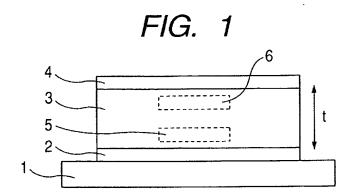


FIG. 2

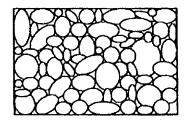


FIG. 3

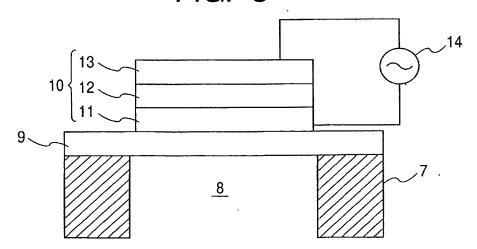


FIG. 4A

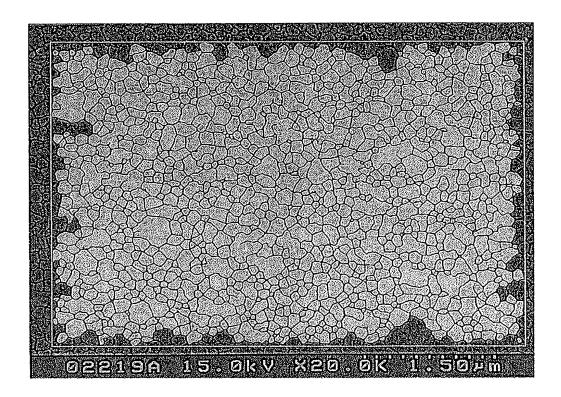
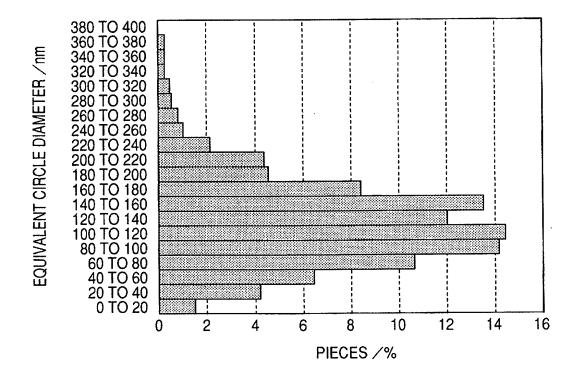


FIG. 4B



INVENTOR: MAKOTO KUBOTA ET AL.
TITLE: PIEZOELECTRIC THIN FILM, METHOD OF
MANUFACTURING PIEZOELECTRIC THIN FILM,
PIEZOELECTRIC ELEMENT, AND INK JET
RECORDING HEAD
Sheet 4 of 6

Docket No.: 03500.109601

4/6

FIG. 5

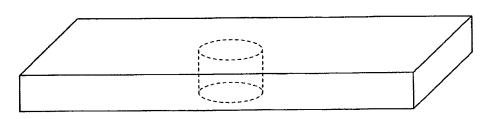


FIG. 6

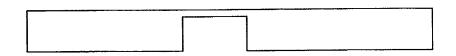


FIG. 7

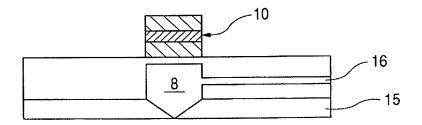


FIG. 8

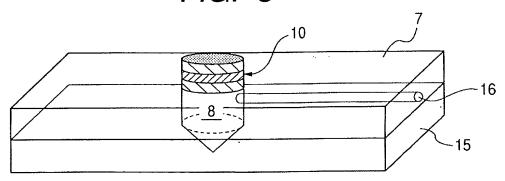


FIG. 9

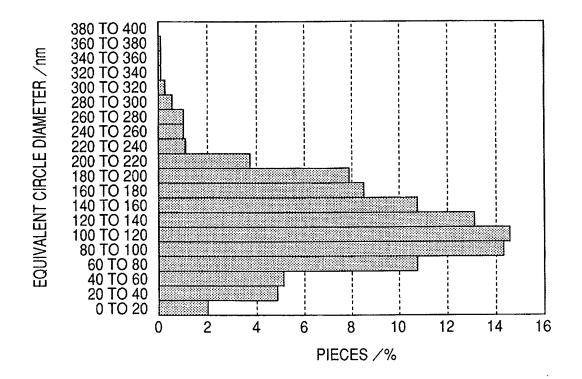


FIG. 10

